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INTELLECTUAL PROPERTY LAW

DATE: November 1, 2007

FILE # 20793/0204682-US0:

FACSIMILE NO.	RECIPIENT AND COMPANY	CONFIRMATION WILL FOLLOW
571-273-0459	PCT Legal Dept Patent & Trademark Office	No

FROM: Julian A. Williams

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NO. OF PAGES: 9
(including cover page)

COMMENTS:

4th Request for corrected Filing Receipt. The Assignment should read
Lecia, Micro systems, CMS GMBH, Wetzlar, Germany

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Customer No.: 07278

Docket No.: 20793/0204682-US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Juergen Paul et. al.

Serial No.: 10/596,723

Filed: June 22, 2006

For: MICROSCOPE SYSTEM AND METHOD FOR OPERATING A MICROSCOPE SYSTEM

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner of Patents and Trademarks
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.
2. There is an error with respect to the following data, which is:

☒ incorrectly entered

☐ omitted.

and/or



UNITED STATES PATENT AND TRADEMARK OFFICE

20793/0204682-USO
UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
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APPL NO.	FILING OR 371(C) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	TOT CLMS	IND CLMS
10/596,723	06/22/2006	2877	2800	20820/0204682-USO	58	2

CONFIRMATION NO. 9921

CORRECTED FILING RECEIPT

OC000000023213275

7278
DARBY & DARBY P.C.
P. O. BOX 5257
NEW YORK, NY 10150-5257

Date Mailed: 04/02/2007

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt Incorporating the requested corrections (if appropriate).

Applicant(s)

Juergen Paul, Wiesloch, GERMANY;
Robert Schuermann, Bergdietikon, SWITZERLAND;
Urs Gomez, Oberembrach, SWITZERLAND;

Assignment For Published Patent Application

Leica Microsystems CMS GmbH, Wetzlar, GERMANY

Power of Attorney: The patent practitioners associated with Customer Number Q7278.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/EP04/53473 12/14/2004

Foreign Applications

GERMANY 103 61 150.9 12/22/2003

If Required, Foreign Filing License Granted: 01/18/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/596,723**

Projected Publication Date: 04/26/2007

Non-Publication Request: No

Early Publication Request: No

Title

Microscope system and method for operating a microscope system

Preliminary Class

356

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Application Data Sheet**Application Information**

Application Type::	Regular
Subject Matter::	Utility
Suggested Group Art Unit::	N/A
CD-ROM or CD-R?::	None
Sequence submission?::	None
Computer Readable Form (CRF)?::	No
Title::	MICROSCOPE SYSTEM AND METHOD FOR OPERATING A MICROSCOPE SYSTEM
Attorney Docket Number::	20820/0204682-US0
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	1
Small Entity?::	No
Petition included?::	No
Secrecy Order in Parent Appl.?::	No

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Correspondence Information

Correspondence Customer Number:: 07278

Representative Information

Representative Customer Number:: 07278

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/EP2004/053473	12/14/04

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Germany	103 61 150.9	12/22/03	Yes

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